

Notice of References Cited	Application/Control No. 10/735,655	Applicant(s)/Patent Under Reexamination HAO	
	Examiner Mark A. Williams	Art Unit 3676	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,154,925 A	12-2000	Miura, Fumiaki	16/338
	B	US-6,618,903 B2	09-2003	Kim, Tae-Gil	16/337
	C	US-6,665,907 B1	12-2003	Lu, Sheng-Nan	16/340
	D	US-6,530,123 B1	03-2003	Wahlstedt, David	16/342
	E	US-6,253,419 B1	07-2001	Lu, Sheng-Nan	16/340
	F	US-6,539,582 B1	04-2003	Chae, Kwon-Byung	16/340
	G	US-6,038,739 A	03-2000	Kato, Hideo	16/342
	H	US-5,854,735 A	12-1998	Cheng, Yung-Long	361/681
	I	US-5,913,351 A	06-1999	Miura, Fumiaki	16/340
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.